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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/597,617	08/25/2006	Tae Kyung Yoo	20506/0205264-US0	3854
7278 DARBY & DA	7590 08/11/200 RBY P.C.	EXAMINER		
P.O. BOX 770	-	PRENTY, MARK V		
Church Street Station New York, NY 10008-0770			ART UNIT	PAPER NUMBER
,			2822	
			MAIL DATE	DELIVERY MODE
			08/11/2008	PAPER

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

	Application No.	Applicant(s)					
Office Action Summary	10/597,617	YOO ET AL.					
omec Action Gammary	Examiner	Art Unit					
	MARK PRENTY	2822					
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply							
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING DA - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period w - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 16(a). In no event, however, may a reply be tim 11 apply and will expire SIX (6) MONTHS from 12 cause the application to become ABANDONEI	I. lely filed the mailing date of this communication. (35 U.S.C. § 133).					
Status							
1) Responsive to communication(s) filed on 25 Au	igust 2006.						
·— · · · · · · · · · · · · · · · · · ·	· · · · · · · · · · · · · · · · · · ·						
3) Since this application is in condition for allowan	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is						
,—	closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.						
Disposition of Claims							
4)⊠ Claim(s) <u>1-20</u> is/are pending in the application.							
4a) Of the above claim(s) is/are withdrawn from consideration.							
5) Claim(s) is/are allowed.							
6)⊠ Claim(s) <u>1,2,4-8 and 10-12</u> is/are rejected.	· · · · · · · · · · · · · · · · · · ·						
7) Claim(s) <u>3,9 and 13-20</u> is/are objected to.							
8) Claim(s) are subject to restriction and/or	8) Claim(s) are subject to restriction and/or election requirement.						
Application Papers							
9)☐ The specification is objected to by the Examine	•						
10)⊠ The drawing(s) filed on <u>09 March 2008</u> is/are: a)⊠ accepted or b)□ objected to by the Examiner.							
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).							
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).							
11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.							
Priority under 35 U.S.C. § 119							
12)⊠ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).							
a)⊠ All b)⊡ Some * c)⊡ None of:							
1. Certified copies of the priority documents have been received.							
2. Certified copies of the priority documents have been received in Application No							
3. Copies of the certified copies of the priority documents have been received in this National Stage							
application from the International Bureau (PCT Rule 17.2(a)).							
* See the attached detailed Office action for a list of the certified copies not received.							
Attachment(s)	_						
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 4) Interview Summary (PTO-413) Paper No(s)/Mail Date							
2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date 5) Notice of Informal Patent Application							
Paper No(s)/Mail Date <u>August 1, 2006</u> . 6) Other:							

This Office Action is in response to the papers filed on August 25, 2006.

Claim 1 is objected to because "wiht" (last line) should read "with."

Claims 2-20 depend on independent claim 1 and are thus similarly objected to.

Claim 3 is further objected to because "multiple-quantum structure" (line 2) should read "multiple-quantum-well structure."

Claims 1, 2, 4-8 and 10-12 are rejected under 35 U.S.C. 102(e) as being anticipated by United States Patent 7,193,246 to Tanizawa et al. (Tanizawa).

As to independent claim 1, Tanizawa discloses a III-nitride compound semiconductor light emitting device (see the entire reference, including the Fig. 8 disclosure) comprising: an active layer 7 emitting light and being interposed between a lower contact layer 4 made of n-GaN (see column 36, lines 34-39) and an upper contact layer 9 made of p-type III-nitride compound semiconductor layer (see column 35, line 32), an n-type electrode layer 12 formed on the lower contact layer, a lattice mismatch-reducing layer 305a made of $ln_xGa_{1-x}N(x>0)$ (see column 37, lines 4-10), grown on the lower contact layer and having a thickness of 200-1000Å (see column 38, lines 1-6), an electron supply layer 305b made of n-Al $_yGa_{1-y}N(y\ge 0)$ (see column 35, lines 26-27, and column 37, lines 4-10) and grown on the lattice mismatch-reducing layer, and a crystal restoration layer 305c made of $ln_zGa_{1-z}N(z>0)$ (see column 37, lines 4-10), grown on the electron supply layer and in contact [with] the active layer (see column 37, lines 1-3).

Claim 1 is thus rejected under 35 U.S.C. 102(e) as being anticipated by Tanizawa.

As to dependent claim 2, Tanizawa's active layer 7 has a single-quantum-well or multiple-quantum-well structure comprising quantum well layer made of $In_xGa_{1-x}N$ (see column 41, lines 60-63).

Claim 2 is thus rejected under 35 U.S.C. 102(e) as being anticipated by Tanizawa.

As to dependent claim 4, Tanizawa's lattice mismatch-reducing layer 305a is undoped (see column 35, line 26).

Claim 4 is thus rejected under 35 U.S.C. 102(e) as being anticipated by Tanizawa.

As to dependent claim 5, the indium content of Tanizawa's lattice mismatch-reducing layer 305a is 0<x≤ 0.4 (see column 37, lines 4-10).

Claim 5 is thus rejected under 35 U.S.C. 102(e) as being anticipated by Tanizawa.

As to dependent claim 6, the Al content of Tanizawa's electron supply layer 305b is $0 < y \le 0.2$ (see column 37, lines 4-10).

Claim 6 is thus rejected under 35 U.S.C. 102(e) as being anticipated by Tanizawa.

As to dependent claim 7, Tanizawa's electron supply layer 305b has a thickness of 10-500Å (see column 38, lines 19-22).

Claim 7 is thus rejected under 35 U.S.C. 102(e) as being anticipated by Tanizawa.

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As to dependent claim 8, the doping concentration of Tanizawa's electron supply layer 305b is 5×10^{17} - 10×10^{21} atoms/cm³ (see column 39, lines 7-18).

Claim 8 is thus rejected under 35 U.S.C. 102(e) as being anticipated by Tanizawa.

As to dependent claim 10, Tanizawa's crystal restoration layer 305c has a thickness of 10-500Å (see column 38, lines 38-41).

Claim 10 is thus rejected under 35 U.S.C. 102(e) as being anticipated by Tanizawa.

As to dependent claim 11, Tanizawa's crystal restoration layer 305c is undoped (see column 35, line 27).

Claim 11 is thus rejected under 35 U.S.C. 102(e) as being anticipated by Tanizawa.

As to dependent claim 12, the indium content of Tanizawa's crystal restoration layer 305c is $0 < x \le 0.4$ (see column 37, lines 4-10).

Claim 12 is thus rejected under 35 U.S.C. 102(e) as being anticipated by Tanizawa.

Claim 3 is objected to as being dependent upon a rejected base claim, but would be allowable over the prior art of record if corrected (see the above objection to claim 3) and rewritten in independent form including all of the limitations of corrected independent claim 1.

Claim 9 and 13-20 are objected to as being dependent upon a rejected base claim, but would be allowable over the prior art of record if rewritten in independent form

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including all of the limitations of corrected independent claim 1 and any intervening

claims.

The prior art of record does not disclose or suggest the allowable III-nitride

compound semiconductor light emitting device as a whole.

Registered practitioners can telephone the examiner at (571) 272-1843. Any

voicemail message left for the examiner must include the name and registration number

of the registered practitioner calling, and the Application/Control (Serial) Number.

Technology Center 2800's general telephone number is (571) 272-2800.

/MARK PRENTY/

Primary Examiner, Art Unit 2822